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Micro- and Nanosystems Information Storage and Processing Systems

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- Examines electromechanical, materials, design, and manufacturing issues of microsystems and their components
- Integrates the knowledge, experience, and capabilities of academic and industrial specialists in many fields
- Contributes to the economically and ecologically sound production of reliable, high performance MEMS and information storage and processing systems
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Featuring rapid publication of important results, Microsystem Technologies examines electromechanical, materials, design, and manufacturing issues of microsystems and their components. It integrates the knowledge, experience, and capabilities of academic and industrial specialists in many fields. Moreover, it contributes to the economically and ecologically sound production of reliable, high performance MEMS and information storage and processing systems.

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